

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 10/050,334  
Filing Date ..... January 15, 2002  
Inventor ..... Vishnu K. Agarwal  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2813  
Examiner..... Tuan H. Nguyen  
Attorney's Docket No. .... MI22-1913  
Title: Capacitor Fabrication Methods and Capacitor Constructions and  
Enhanced Surface

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**


References – See Attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

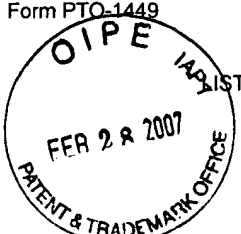
Dated: 28 Feb 2007

By:   
James E. Lake  
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Form PTO-1449 		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1913		SERIAL NO. 10/050,334	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT: Vishnu K. Agarwal			
U.S. PATENT DOCUMENTS				FILING DATE January 15, 2002		GROUP 2813	
*Examiner's Initials	AA	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	6,583,441	06/2003	Moradi et al.			
	AB						
	AC						
	AD						
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	AG						
	AH						
	AI						
FOREIGN PATENT DOCUMENTS							
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							Yes    No
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
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